

PATENT

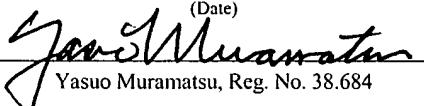
Case Docket No. RYUKA.007AUS
Date: May 31, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shin-ichi Hashimoto et. al.
Appl. No. : 10/672,469
Filed : September 26, 2003
For : ELECTRON BEAM EXPOSURE
APPARATUS, DEFLECTION APPARATUS,
AND ELECTRON BEAM EXPOSURE
METHOD
Group Art Unit : 2881
Batch No. :
Examiner : Quash, Anthony G.

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on

May 31, 2005


(Date)
Yasuo Muramatsu, Reg. No. 38.684

TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS
P. O. BOX 1450, ALEXANDRIA, VA 22313-1450

ATTENTION: OFFICE OF PATENT PUBLICATIONS

Dear Sir:

Enclosed for filing is the Issue Fee for the above-identified application:

(X) Form PTOL-85b.
(X) A check in the amount of \$1,715.00 to cover the issue fee is enclosed.
(X) Return prepaid postcard.


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